## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Mamoru MIYACHI et al.

Application No.: New Application

Filed: June 1, 2006 Attorney Dkt. No.: 107156-00333

For: METHOD FOR FABRICATING SEMICONDUCTOR LASER DEVICE

## PRELIMINARY AMENDMENT

Mail Stop PCT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: June 1, 2006

Sir:

Prior to calculation of the filing fees and initial examination of the application, please amend the above-identified application as shown on the following pages.